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**U.S. PATENT AND TRADEMARK OFFICE  
FACSIMILE TRANSMISSION COVER SHEET**

<p>To: In re the Application of Shunichi SEKI et al.</p> <p>Application No.: 10/686,634</p> <p>Filed: October 17, 2003</p> <p>For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING FORMATION OF BANKS</p>	<p><b>FOR FILING IN THE U.S. PATENT AND TRADEMARK OFFICE</b></p> <p>Group Art Unit: 2826</p> <p>Docket No.: 104741.01</p>
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Examiner: S. WILSON

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From: Daniel A. Tanner, III, Reg. No. 54,734

Prepared By: fpw

Number of Pages Sent (Including cover sheet): 2

**Comments:**

The following paper is attached:  
Abstract (Marked -up Version [1 page])

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